

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| L1 | 8105 | (mems micro\$1electro\$1mechanical) and data near2 stor\$4 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:19 |
| L2 | 727 | 1 and (cars atomic adj resolution adj storage) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:26 |
| L3 | 656 | 2 and (mov\$3 displac\$5 deflect\$4 micro\$1mover) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:20 |
| L4 | 577 | 3 not (@rlad>"20040419" @ad>"20040419") | US-PGPUB; USPAT; EPO; JPO | OR | OFF | 2005/12/09 18:21 |
| L5 | 1 | 4 and (mov\$3 displac\$5 deflect\$4 micro\$1mover) same (selective\$2 align\$4) with (polymer\$2 thermoplastic thermoset pmma epoxy photoresist resist composition coat\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 17:53 |
| L6 | 0 | 4 and (mov\$3 displac\$5 deflect\$4 micro\$1mover) same (pattern\$3 etch\$3) with (polymer\$2 thermoplastic thermoset pmma epoxy photoresist resist composition coat\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 17:54 |
| L7 | 73 | 4 and (mov\$3 displac\$5 deflect\$4 micro\$1mover) same (polymer\$2 thermoplastic thermoset pmma epoxy photoresist resist composition coat\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 17:54 |
| L8 | 73 | 7 and (polymer\$2 thermoplastic thermoset pmma epoxy photoresist resist composition coat\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:23 |
| L9 | 91 | 4 and (method process manufactur\$3 fabricat\$3) near5 (mems micro\$1electro\$1mechanical) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:20 |
| L10 | 55 | 9 not 8 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:10 |

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|-----|-------|---|---|----|-----|------------------|
| L12 | 10244 | (method process manufactur\$3 fabricat\$3) near5 (mems micro\$1electro\$1mechanical) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:20 |
| L13 | 7508 | 12 not (@rlad>"20040419" @ad>"20040419") | US-PGPUB; USPAT; EPO; JPO | OR | OFF | 2005/12/09 18:21 |
| L14 | 8466 | 12 not (@rlad>"20040419" @ad>"20040419") | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/12/09 18:22 |
| L15 | 5763 | 14 and (mov\$3 displac\$5 deflect\$4 micro\$1mover) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:22 |
| L16 | 4026 | 15 and (polymer\$2 thermoplastic thermoset pmma epoxy photoresist resist composition coat\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:23 |
| L17 | 733 | 16 and (polymer\$2 thermoplastic thermoset pmma epoxy photoresist resist composition coat\$3) with (selective\$2 align\$4) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:25 |
| L18 | 596 | 17 and (polymer\$2 thermoplastic thermoset pmma epoxy photoresist resist composition coat\$3) with (pattern\$3 etch\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:25 |
| L19 | 16 | 18 and (cars atomic adj resolution adj storage) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/09 18:26 |